

Docket No.: 060188-0578



PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 53080  
Shinichi IMAI, et al. : Confirmation Number: 4939  
Application No.: 10/619,191 : Group Art Unit: 2125  
Filed: July 15, 2003 : Examiner: Maria N. Von Buhr

For: SYSTEM AND METHOD FOR MONITORING SEMICONDUCTOR PRODUCTION APPARATUS

**PETITION FOR EXTENSION OF TIME**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the time for response to the Final Office Action dated January 12, 2007, now due to expire May 12, 2007, be extended for one month and set to expire on May 12, 2007.

Please charge the extension fee of \$120.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Fogarty  
Registration No. 3691592007 HBARZII 00000003 10619191

01 FC:1251 120.00 DA

**Please recognize our Customer No. 53080  
as our correspondence address.**

600 13<sup>th</sup> Street, N.W.  
Washington, DC 20005-3096  
Phone: 202.756.8000 MEF:EG/cac  
Facsimile: 202.756.8087  
**Date: May 14, 2007**

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